



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 9, 2025

IGI Report Number **LG755533476**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **9.66 X 6.89 X 4.79 MM**

GRADING RESULTS

Carat Weight **3.10 CARATS**

Color Grade **G**

Clarity Grade **VS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

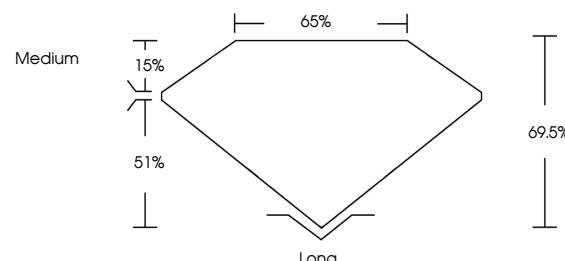
Fluorescence **NONE**

Inscription(s) **IGI LG755533476**

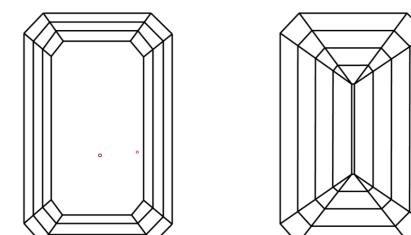
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG755533476
Report verification at igi.org

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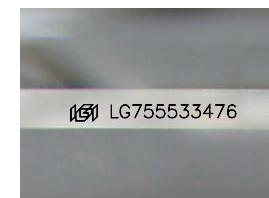
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GRADING RESULTS

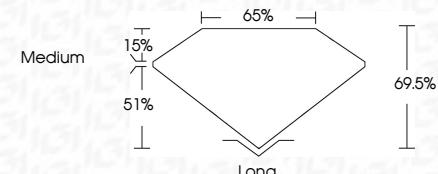
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Sample Image Used



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December 9, 2025	IGI Report No LG755533476	EMERALD CUT	3.10 CARATS	G	VS 2	69.5%	65%	Medium	Long	EXCELLENT	EXCELLENT	NONE	IGI LG755533476
Carat Weight	9.66 X 6.89 X 4.79 MM	Color Grade	Clarity Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Clarity Grade		Very Light	Very Light										
Depth		Light	Light										
Table													
Grade													

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